IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Wayne Renken

Assignee:

SensArray Corporation

Title:

Process Condition Sensing Wafer and Data Analysis System

Application No.:

10/056,906

Filing Date:

January 24, 2002

Examiner:

Garber, Charles D.

Group Art Unit:

2856

Docket No.:

SENS.005US0

Conf. No.:

2359

(formerly M-12467 US)

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO EXAMINER'S REASONS FOR ALLOWANCE

Dear Sir:

The Notice of allowance and fee(s) due in this case, dated September 7, 2004 included the Examiner's statement of reasons for allowance. The statement appears to accurately reflect the discussion between the Examiner and the undersigned attorney regarding the terms "including" and "encompassing" in the limitation "the electronics platform including/encompassing at lease one integrated circuit" of claim 55. It is submitted that the Examiner has given an unreasonably broad meaning to the term "including" in this limitation. In particular, the Examiner viewed a platform that was a component of a circuit as a an example of a "platform including a circuit. "Exminer took the position of broadly taking 'including' to mean the electrode (platform) need only comprise a portion of the circuit as a part of a whole circuit," reasons for allowance page 3. This definition would appear to mean that any component in an assembly "includes" the assembly and is thus believed to be beyond the reasonable meaning of the term "including." Because the term "including" is not believed to have the broad meaning attributed to it by the Examiner, it is submitted that the replacement of "including" by

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"encompassing" does not narrow the scope of claim 55. Thus, claim 55 as amended is submitted to be at least as broad as it was prior to this amendment.

Certificate of Mailing Under 37 CFR 1.8

Franklin Dy

Respectfully submitted,

Peter A. Gallagher

Reg. No.47,584

Attorney Docket No.: SENS.005US0 Application No.: 10/056,906



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December 6, 2004

Mail Stop Issue Fee **Commissioner For Patents** P.O. Box 1450 Alexandria, VA 22313-1450

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Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Return Receipt Postcard;
- (2) This Transmittal Letter (in duplicate);
- (3) Issue Fee Transmittal (1 page-in duplicate);
- (4) Response To Examiner's Reasons For Allowance (2 pages); and
- (5) Check for \$994.00
- The fee has been calculated as shown below: \boxtimes

\boxtimes	Issue Fee	\$ 685.00
\boxtimes	Publication Fee	 300.00
\boxtimes	3 Advance Copies	\$ 9.00

Total: \$ 994.00

Please charge any additional fees required and credit any overpayment to our Deposit Account No. 502664.

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA

22313-1450, on December <u>6</u>, 2004.

Respectfully submitted,

Peter A. Gallagher

Reg. No. 47,584